

Activation Analysis of Oxygen in SnO₂ and Zn₂SnO₄ Crystals

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Synopsis. Oxygen content of SnO₂ and Zn₂SnO₄ crystals grown by the vapor phase method was determined by 14 MeV neutron activation analysis. The oxygen contents in the crystals were a little smaller than the theoretical values. The oxygen deficiency in the crystals was found to be related to their inherent semiconductive properties and density.

Many oxides show a semiconductive property originating in the deviation of oxygen from stoichiometry. The authors have already reported on the growth of SnO₂,¹⁻³⁾ ZnO,⁴⁾ and Zn₂SnO₄⁵⁾ crystals by the vapor phase method. There is a possible of oxygen deficiency in these crystals because they grew with high growth rate. Therefore, informations on the deviation of oxygen from stoichiometry is important to understand their properties.

Activation analysis has been applied to the determination of the oxygen contents in many organic or inorganic compounds.⁶⁻¹⁰⁾ However, its application of oxygen analysis to oxide single crystals is quite a few.

In the present paper, the determination of oxygen contents in SnO₂ and Zn₂SnO₄ crystals was carried out by activation analysis.

Experimental

Samples used in this study were SnO₂ (with/without additives), and Zn₂SnO₄ crystals grown at 1300 °C for 2 hours in porcelain crucible by the vapor phase method. The SnO₂ crystals were obtained from the mixture of SnO₂ and Sn powders, and the Zn₂SnO₄ were also from ZnO and Sn powders. SnO₂ powder (chemical reagent) and ZnO powder (special reagent) were used as reference sample. Sample (ca. 0.1 g) and graphite powder (reagent for spectroscopy, ca. 2.7 g) were mixed sufficiently. The pellets (1.25 cm×1 cm) of the mixed sample were sealed in cylindrical polyethylene containers of 1.5 cm×2 cm. The containers containing samples were transferred from the position of the sample charger to the target area with a pneumatic tube. Samples in the containers were bombarded with 14 MeV neutron with 5×10⁹ n s⁻¹ of neutron intensity for 30 second at target area. After being bombarded, the containers were transferred to a 4.44 cm×5 cm sodium iodide well-type detector with a pneumatic tube to measure the 6.13 MeV γ -ray from 7.35 sec-half-life ¹⁶N produced by the reaction of ¹⁶O(n,p)¹⁶N. A neutron generator (by Toshiba Co. Ltd) accelerates deuterium ion to generate 14 MeV neutron by the ³T(d,n)⁴He reaction: ³T+²d→⁴He+¹n+17.59 (MeV). As a standard sample for calibration, sucrose (guaranteed reagent) was used. The calibration curve on the basis of sucrose-graphite standard sample shows a good linearity in the range of 0 mg to 26.0 mg of oxygen.

Results and Discussion

Table 1 shows the average values on measurements of 3 to 4 times. The values of SnO₂ powder and ZrO₂ powder as reference samples show close agreement with their theoretical values. The values of undoped, antimony-doped and chromium-doped SnO₂ crystals were of the same value, 20.9%. There are no significant differences between the theoretical and the measured values within experimental errors. The oxygen contents is nearly theoretical value. On the other hand, that of vanadium-doped SnO₂ crystals showed clearly a smaller value, 19.9%, than the three others. The density of V-doped crystals was between 5.4 and 5.8. The values were smaller than 6.15 for undoped SnO₂ crystals and 6.12—6.29 for Sb-doped crystals grown at the same vapor phase method. The electrical resistivity of the crystals along the growth direction of an a-axis showed semiconductivity at temperatures from 150° to 400 °C. Accordingly, the semiconductive property of V-doped SnO₂ crystals will be due to oxygen defect.²⁾

In regards to Zn₂SnO₄ crystals grown under the same conditions, dendrite crystals grown in the initial stage of reaction contain somewhat lower oxygen (19.3%) than that (19.6%) of needle crystals grown in the latter stage of reaction. Both Zn₂SnO₄ crystals showed a lower oxygen content than the theoretical value (20.4%). The electrical resistivity of the needle crystals along growth direction was about 10³—10⁴ ohm cm at room temperature.

On a survey of analytical results, the values of oxygen contents in the vanadium-doped SnO₂ and Zn₂SnO₄ crystals were somewhat smaller than the theoretical values, though antimony-doped and

Table 1. Oxygen Content in SnO₂ and Zn₂SnO₄ Crystals by 14 MeV Neutron Activation Analysis

Crystals	Radiated sample Irradiated /mg	Oxygen content	Theoretical value/%
		%	
SnO ₂ powder	80.7	21.0	21.2
ZrO ₂ powder	82.6	26.1	26.0
SnO ₂	83.7	20.9	21.2
Sb-doped SnO ₂	93.9	20.9	21.2
V-doped SnO ₂	95.7	19.9	21.2
Cr-doped SnO ₂	87.4	20.9	21.2
Zn ₂ SnO ₄ (needle)	87.1	19.6	20.4
Zn ₂ SnO ₄ (dendrite)	89.8	19.3	20.4

chromium-doped ones had nearly theoretical value. Accordingly, the crystals with low oxygen contents used in the present experiments will have an oxygen deficiency leading to semiconductivity.

References

- 1) T. Matsushita and I. Yamai, *Nippon Kagaku Kaishi*, **1974**, 1893.
 - 2) R. Yoshida, Y. Yoshida, J. Saito, Y. Yamada, K. Kodaira, T. Matsushita, and I. Yamai, *J. Mater. Sci. Lett.*, **2**, 741 (1983).
 - 3) T. Matsushita, Y. Yamai, K. Kodaira, J. Saito, and R. Yoshida, "Bull. Facul. Eng., Hokkaido University," No. 122, 41 (1984).
 - 4) K. Kodaira, T. Matsushita, J. Saito, and R. Yoshida, *Chem. Lett.*, **1975**, 589.
 - 5) R. Yoshida, Y. Yoshida, I. Yamai, K. Kodaira, and T. Matsushita, *J. Cryst. Growth*, **36**, 181 (1976).
 - 6) I. Fujii, H. Muto, K. Ogawa, and T. Tani, *J. Atom. Energ. Soc. Jpn*, **5**, 455 (1963).
 - 7) K. Yabe, S. Ueda, Y. Hasegawa, and T. Sato, *Radioisotopes*, **21**, 80 (1972).
 - 8) M. Chiba and T. Ando, *Bunseki Kagaku*, **31**, 294 (1982).
 - 9) T. Nagashima, M. Kamo, H. Tanaka, and Y. Inomata, *Yogyo Kyokai Shi*, **88**, 511 (1980).
 - 10) H. Ishikawa, M. Nakane, and Y. Miyake, *Nippon Kagaku Kaishi*, **1973**, 56.
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